

<b>Notice of References Cited</b>	Application/Control No. 09/955,370	Applicant(s)/Patent Under Reexamination CONNOR ET AL.	
	Examiner Kim T. Huynh	Art Unit 2112	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,381,713 B1	04-2002	Irvin et al.	714/701
	B	US-2002/0021701	02-2002	Lavian et al.	370/401
	C	US-2003/0140153	07-2003	LAWRENCE, THOMAS DAVID	709/230
	D	US-6,633,575	10-2003	Koodli, Rajeev	370/412
	E	US-6,665,724	12-2003	Lawrence, Thomas David	709/230
	F	US-2005/0157733	07-2005	Liu et al.	370/401
	G	US-6,633,575	10-2003	Koodli, Rajeev	370/412
	H	US-6,650,640	11-2003	Muller et al.	370/392
	I	US-2003/0140153	07-2003	LAWRENCE, THOMAS DAVID	709/230
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.